Improving light collection efficiency of silicon photomultipliers through the use of metalenses

A.A. Loya Villalpando*, W.T. Chen, R. Guenette, J. Martin-Albo, J.S. Park, F. Capasso

*alvaro.loya@nikhef.nl

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Outline

> Motivation

• SiPM coverage in particle detectors

Metalenses

- introduction what and why
- working principle
- SiPMs with metalenses
 - experimental design
 - beam profiling and metalens efficiency
- Results and Outlook

Motivation

Particle detectors with SiPMs

Many experiments could benefit from increase in light collection by SiPMs
Οvββ, dark matter, event neutrino, etc.



DARWIN Collaboration

DARWIN

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Light collection of SiPMs

Why SiPMs?

- single p.e. resolution
- low voltage + high gain
- compact (radiopurity)
- improving VUV sensitivity

Why fewer/smaller SiPMs?

- cost
- simpler electronics
- fewer readout channels
- recycle existing infrastructure

Why increase light collection of SiPMs?

- track/position reconstruction
- energy resolution/ threshold
- trigger efficiency

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~ 1% area coverage by SiPMs in NEXT



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Metalenses

What are Metalenses?

- multifocal diffractive lenses
- optimized for specific/ multiple wavelength(s)
- nanostructures on thin substrate

click here for a video introduction!

optical image of single metalens

schematic of metalens nanostructures



SEM image of nanofins (metasurfaces)



Images: Khorasaninejad et al., Science 352, 6290 (2016)

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Why use metalenses?

Advantages

- low cost
 - currently < \$10 each
 - smaller SiPM + metalens < larger sipm (3 to 5X)
- compact
 - radiopurity
 - simple mechanical integration
- simple fabrication
 - single layer lithography
 - mass production ok

Potential applications

- replacement of refractive lenses
- particle detectors!



array of 1 cm diameter metalenses λ_{d} = 632 nm (this work)

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Light diffraction by metalenses



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increasing deflection angle

Light focused by metalenses

0th order (~ 20% eff) 1st order (~ 38% eff) 2nd order (~15% eff) 3rd order (~ 5% eff)

incident light



* efficiency and location of foci by design - adjustable

metalens

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SiPMs with Metalenses

Concept & questions

- concept
 - large photodetection area coverage by metalenses projected onto (small) SiPMs

• questions

- optimal SiPM location?
- dependence on SiPM size?
- how much can the light collection be increased?
- what influences this increase?
- what is the light transmission efficiency of the metalenes?



Experimental design

- 1.3 x 1.3, 3 x 3 and 6 x 6 mm² SiPMs (Hamamatsu S13370) \bigcirc
- signal as a function of distance from the metalens location
 - with and without metalens in place Ο

1st order focal point



SiPMs' signals

SiPM signals with metalens

SiPM signals without metalens

signal shape without metalens

1/r² dependence



- signal shape with metalens
 - projected beam profile + metalens efficiency
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Signal shape with metalenses





signal (beam diameter, intensity)

SiPM

Beam profiling

- **Thorlabs BP209**
 - beam width (> 13.5% of max intensity) 0



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4000

x-profile

Bessel Fitted Data

Gaussian Fitted Data

Measured Data

-4000

-2000

0

Position [µm]

2000

100

80

Signal shape and beam width

SiPM signal with metalens

measured beam width



Metalens efficiency measurements

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normal incidence efficiency

- 10 mm diameter beam, variable aperture power detector
- measure transmitted power as a function of distance from the metalens

angular efficiency

- 2 mm diameter beam centered on metalens, 10 mm aperture power detector fixed at 5mm from metalens
- measure transmitted power as a function of metalens rotation angle



Linear efficiency results

• consequence of combined foci contributions



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Angular efficiency results



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Signal increase

- signal multiplication factor = signal with metalens divided by signal without metalens
- signal increase improves with decreasing SiPM area
 - increased area coverage (metalens area/ SiPM area)

6-7X signal increase for smallest SiPM!



Conclusions and outlook

Conclusions

- Increasing light collection would benefit several experiments
- Metalenses are a practical and cost-effective solution
- Metalenses are most effective when coupled with SiPMs of small active area, providing an increase of 6-7X in light collection at ~630 nm
 - similar expected at ~430 nm

Outlook

- Detector optimization/ implementation
 - size/shape of metalenses
 - location and spacing of metalenses and SiPMs
 - saturation effects
 - low temperature performance
- Design and fabrication of metalenses
 - VUV (currently down to ~260 nm, wavelength shifting substrate, other nanomaterials)
 - converging foci to maximize light collection

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Bonus Material

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Metalens Equations

$$arphi_{n\!f}(x,y)=rac{2\pi}{\lambda_d}\Big(f-\sqrt{x^2+y^2+f^2}\Big)$$

$$\frac{d\phi}{dr} = \frac{N}{p} = \frac{2\pi}{\lambda_d}\sin\theta_N$$

 $\Phi = \phi$ = phase profile

 θ_{N} = deflection angle of N order

$$f = focal point N; N = 1,2,3,...$$

 λ_{d} = design wavelength

p = local periodicity on metalens

Further details: Yu et al., Science 334, 333 (2011)

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Local periodicity of metalens





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SEM image of nanofins with 11um periodicity



Image: Yu et al., Science 334, 333 (2011)

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Metalens vs ordinary lenses







Image: Laptop Media

Image: roadtovr.com

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Projected beam ellipticity



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Signal increase dividing all signals with metalens by signal without metalens at metalens location

Light focused by metalenses

0th order (~ 20% eff) 1st order (~ 38% eff) 2nd order (~ 15% eff) 3rd order (~ 5% eff) *

incident light

* efficiency and location of foci by design - adjustable

metalens

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